

## Abstract

Accurately detected is polycrystalline silicon with use of a sensor to reliably discharge the polycrystalline silicon, which is a discharge target, to the outside of a conveyance section. A polycrystalline silicon conveyance device (1) includes: a conveyance section (30) that has a discharge end portion (31) from which polycrystalline silicon (S) is discharged and that is configured to convey the polycrystalline silicon (S) to discharge the polycrystalline silicon (S) from the discharge end portion (31); a first sensor (12) configured to detect the polycrystalline silicon (S) from a plurality of directions above the conveyance section (30); and a control section (20) configured to control driving of the conveyance section (30) on the basis of a result of detection of the polycrystalline silicon (S) by the first sensor (12).

(Figure 1)